



**ELECTRONIC COPY**

LG788679030  
Report verification at igi.org



April 3, 2026

IGI Report Number **LG788679030**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUSHION BRILLIANT**

Measurements **17.40 X 12.31 X 7.85 MM**

**GRADING RESULTS**

Carat Weight **12.88 CARATS**

Color Grade **F**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

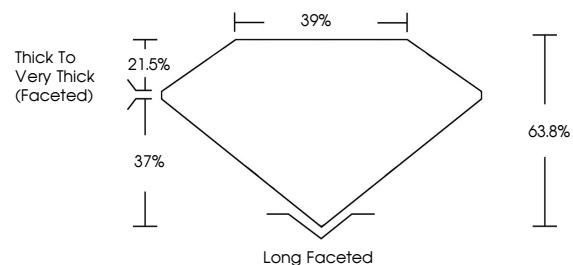
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG788679030**

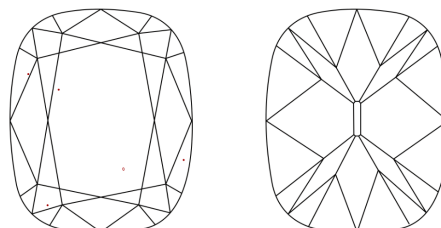
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

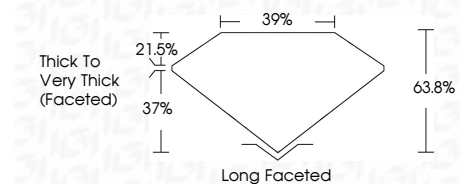
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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IGI Report No LG788679030  
**CUSHION BRILLIANT**  
12.88 CARATS  
F  
12.88 CARATS  
F  
17.40 X 12.31 X 7.85 MM  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle  
Thick to Very Thick (Faceted)  
37%  
63.8%  
39%  
Long Faceted  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)  
**EXCELLENT**  
**EXCELLENT**  
**NONE**  
IGI LG788679030

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